



25237

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

K. Hashimoto et al.

Group Art Unit: 2823

Application No.: 10/028,429

Examiner: K. Nguyen

Filed: December 28, 2001

Docket No.: 107317-00039

For: DRY ETCHING WITH REDUCED DAMAGE TO MOS DEVICE

PETITION FOR EXTENSION OF TIME

Commissioner of Patents
Washington, D.C. 20231

April 9, 2003

Sir:

Applicant(s) petition for an extension of time for one month for response to the outstanding Office Action dated December 13, 2002 from March 13, 2003 to April 13, 2003.

The Commissioner is hereby authorized to charge any fee deficiency or credit any overpayment associated with this communication to Deposit Account No. 01-2300.

Respectfully submitted,


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